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Docket: 0756-1614

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of)
Takeshi FUKUNAGA et al.)
Serial No. 08/781,920) Art Unit: 1112
Filed: December 30, 1996) Examiner: M. Padgett
For: METHOD OF FABRICATING)
A SEMICONDUCTOR DEVICE)
UTILIZING A CATALYST)
MATERIAL SOLUTION) Date: September 23, 1998

INFORMATION DISCLOSURE STATEMENT

Assistant Commissioner for Patents

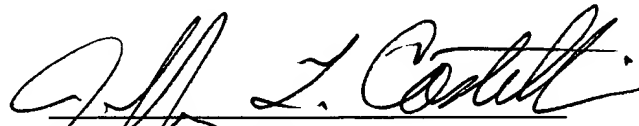
Washington, D.C. 20231

Sir:

In accordance with the provisions of 37 C.F.R. 1.56 and 37 C.F.R. 1.97-1.99, it is requested that the references listed on the attached Form PTO-1449 be made of record in the above-identified application.

Copies of the references are submitted herewith in accordance with 37 C.F.R. 1.98(a).

Respectfully submitted,


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